INTERNATIONAL SEARCH REPORT

International Application No √/FR2004/001634

A. CLASSIFICATION OF SUBJECT MATTER IPC 7 C30B1/02 C30B29/06

C30B25/02

H01L21/00

10 0

B82B3/00

According to International Patent Classification (IPC) or to both national classification and IPC

B. FIELDS SEARCHED

Minimum documentation searched (classification system followed by classification symbols)

IPC 7

C30B H01L B82B

Documentation searched other than minimum documentation to the extent that such documents are included in the fields searched

Electronic data base consulted during the international search (name of data base and, where practical, search terms used)

EPO-Internal, PAJ, INSPEC, WPI Data

C. DOCUMENTS CONSIDERED TO BE RELEVANT

Category °	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No.	
A	US 5 827 773 A (VOUTSAS TOLIS) 27 October 1998 (1998-10-27) the whole document	1	
A	KUNII ET AL.: "Solid Phase lateral epitaxy of chemical vapor deposited amorphous silicon by furnace annealing" JOURNAL OF APPLIED PHYSICS, vol. 54, no. 5, May 1983 (1983-05), pages 2847-2849, XP002274241 NEW YORK US cited in the application the whole document -/	1	
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A documer conside filing da *L* documer which is citation *O* documer other m *P* documer	which may throw doubts on priority claim(s) or cited to establish the publication date of another or other special reason (as specified) t referring to an oral disclosure, use, exhibition or carnot be considered to reason (as specified) t referring to an oral disclosure, use, exhibition or carnot be considered to involve an in	the application but cory underlying the aimed invention be considered to comment is taken alone aimed invention rentive step when the re other such docu-s to a person skilled	

Date of mailing of the international search report

05/11/2004

Authorized officer

Cook, S

Name and mailing address of the ISA

Date of the actual completion of the international search

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27 October 2004

INTERNATIONAL SEARCH REPORT

International Application No FR2004/001634

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INTERNATIONAL SEARCH REPORT

Information on patent family members

International Application No FR2004/001634

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.Form PCT/ISA/210 (patent family annex) (January 2004)